



Atty. Dkt. No. 039153-0306 (F0793)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Piao et al.

Title: CONFIGURABLE RETICLE FOR
LITHOGRAPHY AND A METHOD
OF MAKING INTEGRATED
CIRCUITS USING SUCH A
RETICLE

Appl. No.: 09/775,059

Filing Date: 02/01/2001

Examiner: Unknown

Art Unit: 2811

ATTENTION: **DRAWING REVIEW BRANCH**
U.S. Commissioner of Patents and Trademarks
Washington, D.C. 20231

CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on the date below. <u>Chris Escavaille</u> (Printed Name) <u>Chris Escavaille</u> (Signature) <u>March 29, 2002</u> (Date of Deposit)
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TC 1700

REQUEST TO APPROVE DRAWING CHANGES

The Applicant hereby proposes to revise the drawings as hand-corrected on the attached drawing sheet (Fig. 2). The Applicant will submit new formal drawings upon allowance of the application. Approval of the proposed drawing changes is hereby respectfully requested.

Respectfully submitted,

Date 3-29-02
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